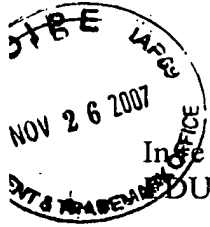


SW:AT



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT APPLICATION of: EDWIN
GUARD N JOSEPHUS KRIJNEN

Confirmation Number: 6215

Application No.: 10/779,864

Group Art Unit: 2877

Filed: February 18, 2004

Examiner: TURNER, SAMUEL A.

Title: LITHOGRAPHIC APPARATUS, AND DEVICE MANUFACTURING METHOD, AND
METHOD FOR DETERMINING Z-DISPLACEMENT

REQUEST FOR RECONSIDERATION

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA. 22313-1450

Dear Sir:

In response to the Final Office Action mailed August 30, 2007 ("Final Action"),
please reconsider the above-identified application based on the following remarks.

OK TO ENTER: /SAT/